

INFORMATION DISCLOSURE STATEMENT BY APPLICANT  (Use as many sheets as necessary)	Application 10/538,132		Our File No. P/2850-109	
	Applicant Toshiyuki KAWAGUCHI et al.			
	Filing Date June 9, 2005	Group Art Unit 1773		

## U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-5,827,445	10-1998	Yoshida et al.	252	62.54	
	US-6,448,491	09-2002	Sato et al.	174	35	

## FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	2002-118008	04-2002	Japan			X	
	2000-348916	12-2000	Japan			X	
	2000-307287	11-2000	Japan			X	
	10-229292	08-1998	Japan			X	
	10-308596	11-1998	Japan			X	
	9-93034	04-1997	Japan			X English Language equivalent (US 5,827,445)	
	9-181476	07-1997	Japan			X	
	2002-084091	03-2002	Japan			X English Abstract only	
	7-212079	08-1995	Japan			X English Language equivalent (US 6,448,491)	
	2003-343627	12-2003	Japan			X English Abstract only	
	2003-343631	12-2003	Japan			X English Abstract only	
	2003-115692	04-2003	Japan			X English Abstract only	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Japanese Office Action (for Japanese Patent Appl. No. 2004-059115) dated May 12, 2009 (with English translation).
	Japanese Office Action (for Japanese Patent Appl. No. 2004-018466) dated May 12, 2009 (with English translation).

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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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	US-					
	US-					
	US-					
	US-					
	US-					

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						Yes	No

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Japanese Office Action (for Japanese Patent Appl. No. 2003-338422) dated May 12, 2009 (with English translation).
	Shigehiro OHNUMA et al., "Noise suppression effect by nano-granular magnetic films at Ghz frequency", <i>Proceedings of the 131<sup>st</sup> Conference</i> , pp 17-24, July 4, 2003; The Magnetics Society of Japan (Eng. Abstract included).
	Masaki ABE et al., "Low temperature fabrication of ferrite films and their noise spression characteristics", <i>Proceeding of the 131<sup>st</sup> Conference</i> , pp 25-31, July 4, 2003; The Magnetics Society of Japan (Eng. Abstract included).
	Ki Hyeon Kim et al., "Applications of Spin Sprayed Ferrite Films on Coplanar Transmission Line for RF Noise Supression", <i>Trans. Magn. Soc. Japan</i> , 3(4):133-136 (2003).
	International Search Report for PCT/JP2004/003951 dated July 6, 2004.

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